Update Search

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	147721	resist\$1 with (mask\$3 pattern\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/05/11 15:43
L2	38011	1 same thick\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/05/11 15:31
L3	598	2 and (half adj tone\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/05/11 15:44
L4	178	3 and (tft\$1 (thin adj film adj transistor\$1))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/05/11 15:33
L5 ,,	62	4 and (ash\$3 with resist)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/05/11 15:44

Interference Search

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L7	34441	resist\$1 with (mask\$3 pattern\$4)	US-PGPUB	OR	OFF	2007/05/11 15:43
L8	187	7 same (half adj tone\$1)	US-PGPUB	OR	OFF	2007/05/11 15:44
L9	7	8 same (ash\$3 with resist)	US-PGPUB	OR	OFF	2007/05/11 15:45
L10	4	9.clm.	US-PGPUB	OR	OFF	2007/05/11 15:45



PALM INTRANET

Day: Friday Date: 5/11/2007 Time: 16:41:31

Inventor Name Search Result

Your Search was:

Last Name = DEJIMA First Name = YOSHIO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09010688	6259494	150		REPAIRABLE THIN FILM TRANSISTOR MATRIX SUBSTRATE HAVING OVERLAPPING REGIONS BETWEEN AUXILIARY CAPACITANCE ELECTRODES AND DRAIN BUS	DEJIMA, YOSHIO
<u>09861796</u>	<u>6614494</u>	150		REPAIRABLE THIN FILM TRANSISTOR MATRIX SUBSTRATE AND METHOD OF REPAIRING THE SUBSTRATE	DEJIMA, YOSHIO
10795787	Not Issued	80		Thin film transistor substrate and method for fabricating the same	DEЛMA, YOSHIO
10848610	Not Issued	41		Method of manufacturing substrate for display and method of manufacturing display utilizing the same	DEJIMA, YOSHIO

Inventor Search Completed: No Records to Display.

Search Another: Inventor Last Name First Name

Dejima Yoshio Search

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